AMENDMENTS TO THE CLAIMS

- 1-35. (Cancelled)
- 36. (NEW) A web fabrication process for manufacturing a plurality of light-emitting panels, the process comprising:

providing a first substrate;

disposing a plurality of micro-components on the first substrate, each micro-component emitting light when exposed to a triggering voltage;

disposing a second substrate on the first substrate such that the plurality of microcomponents are disposed between the first substrate and the second substrate; and dicing the first and second substrates to form the plurality of light-emitting panels.

- 37. (NEW) The process of claim 36, wherein providing the first substrate comprises pulling a web of the first substrate off of a roll.
- 38. (NEW) The process of claim 36, wherein further comprising forming a plurality of sockets in the first substrate.
- 39. (NEW) The process of claim 36, further comprising disposing at least two electrodes by each of the micro-components.
- 40. (NEW) The process of claim 39, wherein disposing comprises placing the two electrodes to apply a voltage across each micro-component.
- 41. (NEW) The process of claim 40, wherein placing the two electrodes comprises placing the two electrodes so that each micro-component emits radiation when the triggering voltage is provided to the two electrodes.
- 42. (NEW) The process of claim 36, further comprising forming a plurality of sockets in the first substrate and wherein disposing the plurality of micro-components comprises disposing each micro-component at least partially within each socket.

43. (NEW) The process of claim 42, wherein providing the first substrate comprises forming the first substrate with a plurality of material layers and forming the plurality of sockets comprises selectively removing portions of the material layers to form a plurality of cavities.

- 44. (NEW) The process of claim 42, wherein forming the plurality of sockets comprises patterning the first substrate with a plurality of cavities.
- 45. (NEW) The process of claim 44, further comprising disposing a material layer on the first substrate so that the material layer conforms to a shape of each socket and disposing at least one electrode between the first substrate and the material layer.
- 46. (NEW) The process of claim 44, further comprising disposing a plurality of material layers on the first substrate so that the plurality of material layers conform to a shape of each socket and disposing at least one electrode within the plurality of material layers.
- 47. (NEW) The process of claim 42, wherein providing the first substrate comprises forming the first substrate by disposing a plurality of material layers and forming the plurality of sockets comprises selectively removing portions of the material layers to form a plurality of cavities.
- 48. (NEW) The process of claim 47, further comprising disposing an electrode on at least one of the first substrate and the second substrate.
- 49. (NEW) The process of claim 48, wherein the electrode is disposed between two material layers of the plurality of material layers.
- 50. (NEW) The process of claim 48, further comprising disposing an enhancement material near each socket.

51. (NEW) The process of claim 50, wherein disposing the enhancement material comprises disposing a passive electrical component.

52. (NEW) The process of claim 50, wherein disposing the enhancement material comprises:

suspending the enhancement material in a liquid; and

flowing the liquid over the first substrate such that the enhancement material settles in each socket.

- 53. (NEW) The process of claim 50, wherein disposing the enhancement material comprises disposing the enhancement material to be aligned with a shape of the sockets.
- 54. (NEW) The process of claim 36, further comprising providing control electronics for the light-emitting panels.
- 55. (NEW) The process of claim 36, wherein providing the first substrate, disposing the plurality of micro-components, disposing the second substrate, and dicing the first and second substrates is performed as a continuous high-speed inline process.
- 56. (NEW) The process of claim 36, wherein providing the second substrate comprises pulling a web of the second substrate off of a roll.
- 57. (NEW) The process of claim 50, wherein disposing the enhancement material comprises disposing an active electrical component.
- 58. (NEW) A web fabrication process for manufacturing a plurality of light-emitting panels, comprising:

providing a first substrate comprising a plurality of channels; and

weaving a single micro-component through the plurality of channels, the microcomponent having a cylindrical shape and emitting radiation when exposed to a trigger voltage.

- 59. (NEW) The process of claim 58, wherein the channels comprise a plurality of ends and the process further comprises heating the micro-component to allow the micro-component to bend around the end of each channel.
- 60. (NEW) The process of claim 58, further comprising weaving a plurality of micro-components, wherein each micro-component emits a specific color of visible light when exposed to the trigger voltage.
- 61. (NEW) The process of claim 58, further comprising coating each channel with a specific color phosphor.